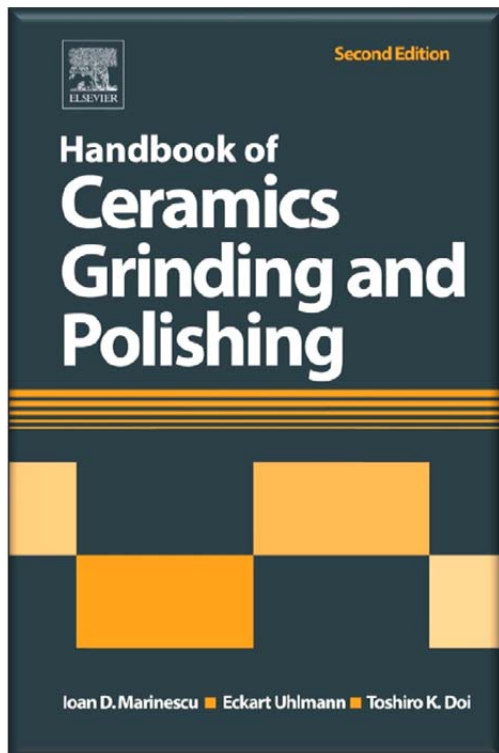


## Handbook of Ceramics Grinding and Polishing 第2版

Edited by Toshiro Doi, Ioan D. Marinescu and Eckart Uhlmann



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**Just  
Published!**

### Description

Handbook of Ceramics Grinding and Polishing meets the growing need in manufacturing industries for a clear understanding of the latest techniques in ceramics processing. The properties of ceramics make them very useful as components—they withstand high temperatures and are durable, resistant to wear, chemical degradation, and light. In recent years the use of ceramics has been expanding, with applications in most industry sectors that use machined parts, especially where corrosion-resistance is required, and in high temperature environments.

However, they are challenging to produce and their use in high-precision manufacturing often requires adjustments to be made at the micro and nano scale. This book helps ceramics component producers to do cost-effective, highly precise machining. It provides a thorough grounding in the fundamentals of ceramics—their properties and characteristics—and of the abrasive processes used to manipulate their final shape as well as the test procedures vital for success.

The second edition has been updated throughout, with the latest developments in technologies, techniques, and materials. The practical nature of the book has also been enhanced; numerous case studies illustrating how manufacturing (machining) problems have been handled are complemented by a highly practical new chapter on the selection and efficient use of machine tools.

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### 第2版に新たに追加されたコンテンツ:

- New chapter on Fundamentals of Abrasive Machining
- New chapter on Requirements for Machine Tools for Ceramics Machining
- Additional material on nano ceramics and recent trends
- New material on Magnetic Finishing of Ceramics, ELID Grinding of Ceramics
- Additional case studies on products from Corning, Ceradine, NGK (Japan), Kyocera and Coors.
- More emphasis on insights and experience-based advice from the authors.

下記サイトにて抄録をご覧ください。

<http://www.sciencedirect.com/science/book/9781455778584>

**好評  
発売中**

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